

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kouta NAGANO et al.

Application No.: 10/519,175

Filed: December 20, 2004

For: METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE

Customer No.: 20350

Confirmation No. 5251

Examiner: Monica D. Harrison

Technology Center/Art Unit: 2813

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 29, 2007 (e-filed)

Sir:

In response to the Office Action mailed April 27, 2007, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.